

Electronic Supplementary Information for

Light-directed on-chip shape transformation of a single gold nanoparticle

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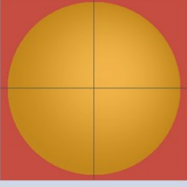
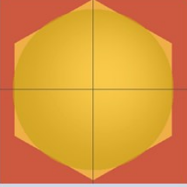


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Table S1 Geometry setting of different shaped Au NPs (simplified from the SEM images in Figure 1c) for FDTD simulations

Time (s)	0	4	6	10
FDTD Geometry				
	Sphere	Hexagon	Pentagon	Prism
Size (nm)	$\Phi 85$	$\Phi 80, 45*20^a$	$\Phi 76, 46*20^a$	$90*60$
Volume(nm^3)	$3.2*10^5$	$3.4*10^5$	$2.9*10^5$	$3.1*10^5$

a) Size of the facet in a format of $l*h$. Here l is the length of the facet while h is the height of the facet.

Table S2 Laser-induced growth, etching and ripening of Au NPs under different irradiation conditions

Power (mW) Conc. (mM) ^a	1	2	3	4
5	growth	growth	growth	ripening
25	growth	growth	ripening	ripening
50	dissolution	dissolution	dissolution	dissolution

a) Concentration of HAuCl_4 in aqueous solution.

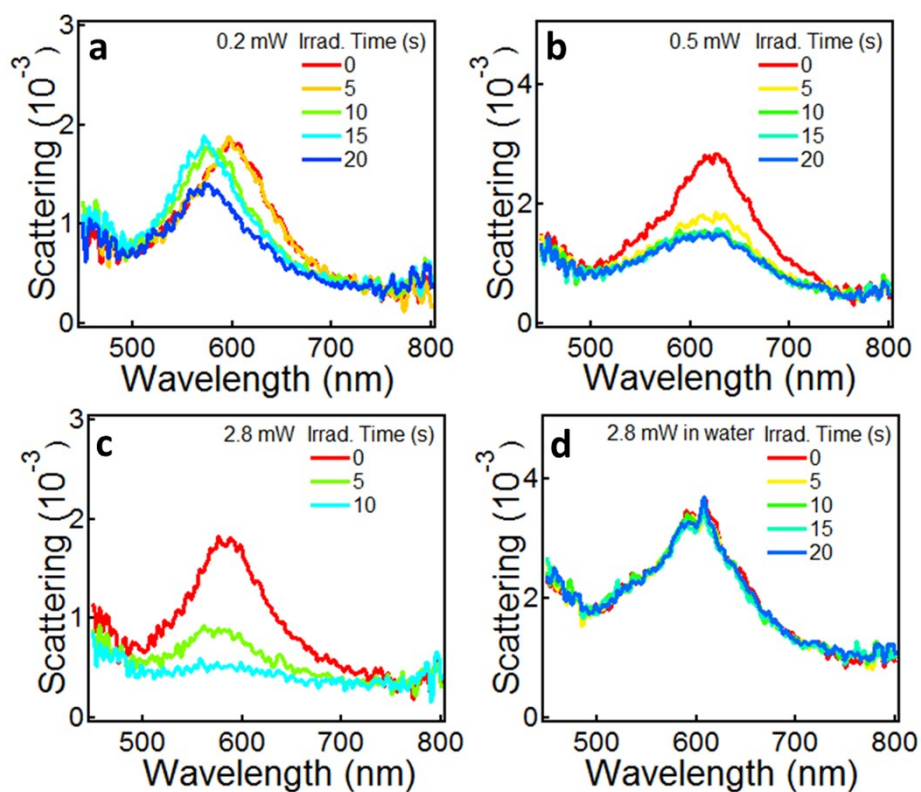


Fig. S1 (a-c) Dark field scattering spectra showing kinetics of AuNPs in HAuCl_4 solution (25 mM) at different irradiation powers. (a) 0.2 mW, (b) 0.5 mW, (c) 2.8 mW. (d) Dark field scattering kinetics of AuNPs in water as a control at irradiation power of 2.8 mW.

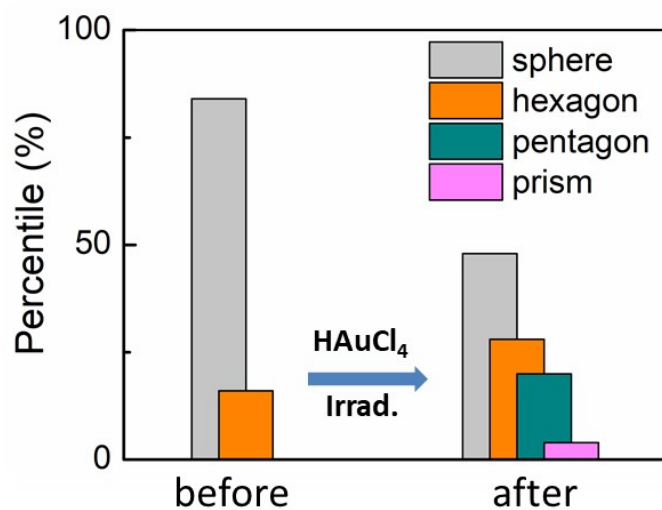


Fig. S2 The statistic histogram of Au NPs shape before and after the irradiation. HAuCl_4 . Concentration: 20 mM. Irradiation power: 4 mW.

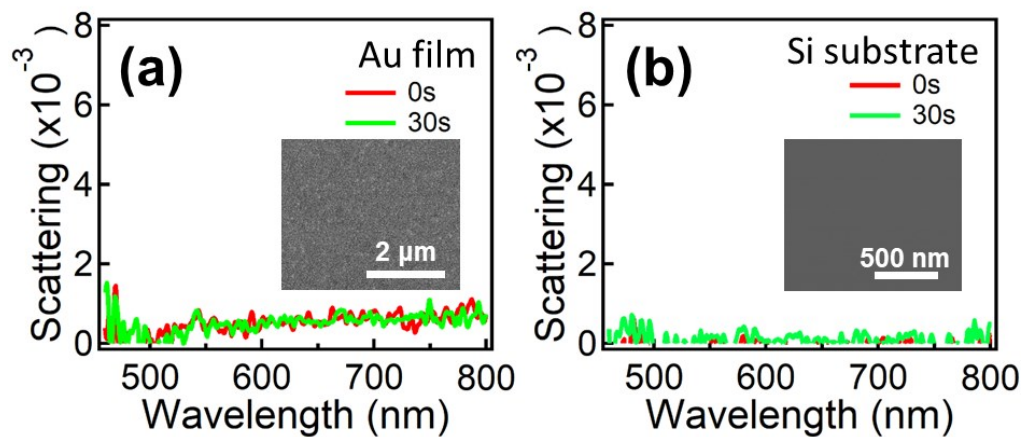


Fig. S3 Scattering spectra before and after laser irradiation (a) on Au film. HAuCl_4 . Concentration: 50 mM. Irradiation power: 8 mW. (b) on Si substrate. HAuCl_4 . Concentration: 25 mM. Irradiation power: 8 mW.

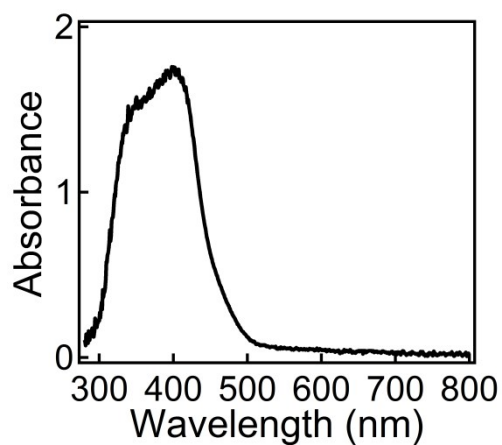


Fig. S4 UV-Vis absorbance of HAuCl_4 aqueous solution (10 mM).

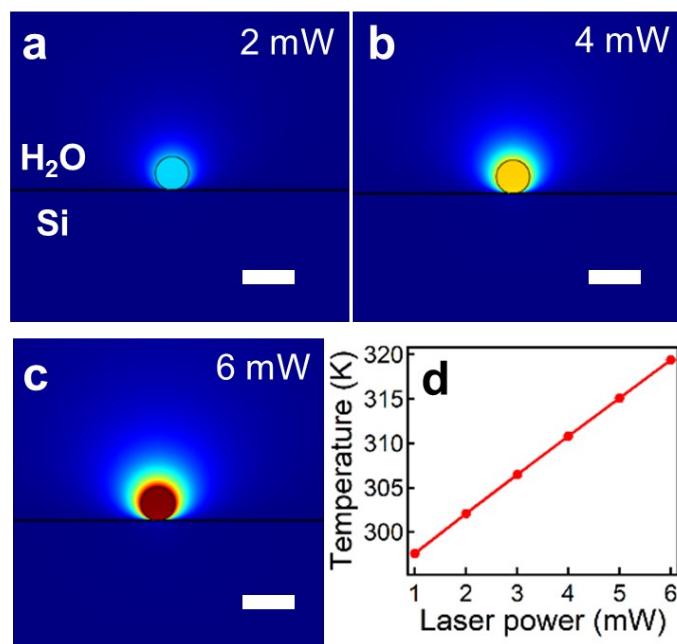


Fig. S5 Temperature distribution around Au NPs on Si substrate with water medium. Irradiation power: (a) 2 mW, (b) 4 mW, (c) 6 mW. Scale bars are 100 nm. (d) Change of Au surface temperature with irradiation power.

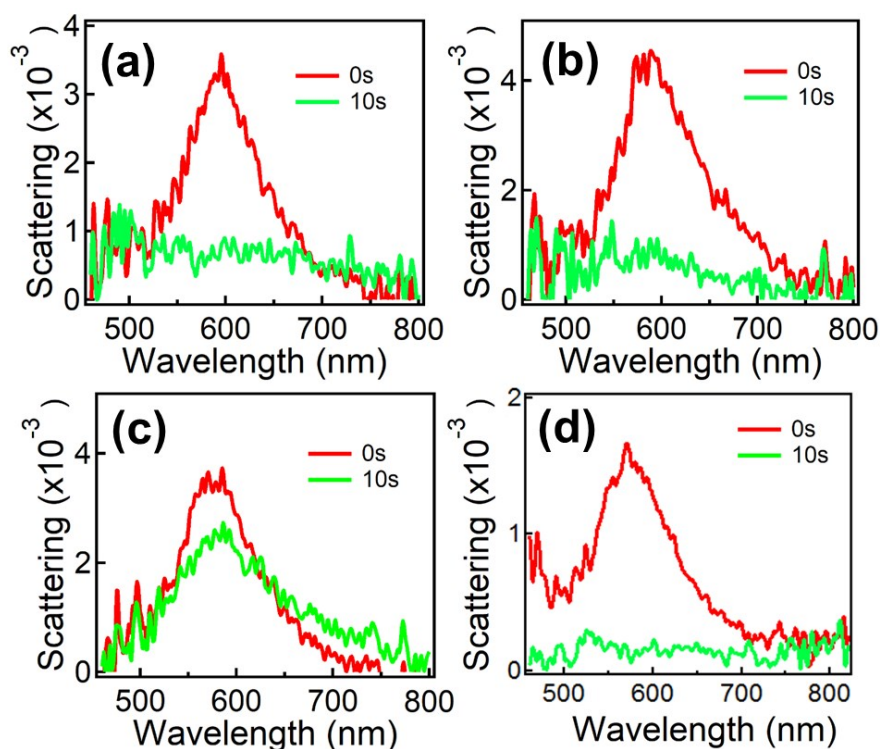


Fig. S6 Scattering spectra of Au NPs before and after the irradiation under different conditions. (a) in 5 mM HAuCl_4 solution containing 50 mM HCl. (b) in 5 mM HAuCl_4 solution containing 50 mM NaCl. (c) in 50 mM NaAuCl_4 solution (pH=6). (d) in 50 mM HAuCl_4 solution.

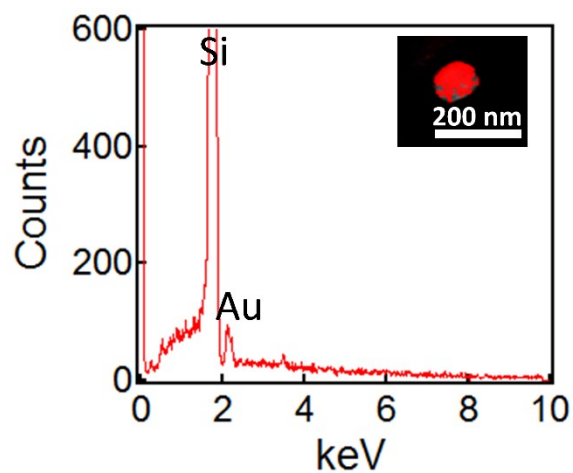


Fig. S7 The EDX spectrum of the irradiated Au NP on Si substrate. Inset is the EDX mapping of Au element overlapping with the SEM image.

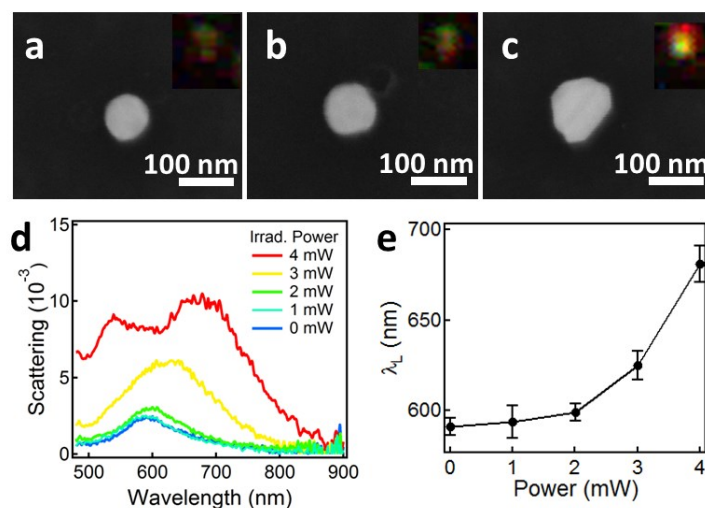


Fig. S8 Power dependent growth of Au NPs in the presence of HAuCl_4 solution (5mM). (a-c) SEM images of Au NPs after the irradiation (30 s). irradiation power: a) 2 mW, b) 3 mW, c) 4 mW. d) Change of scattering spectra with irradiation power. and e) the corresponding change of the plasmon peaks.

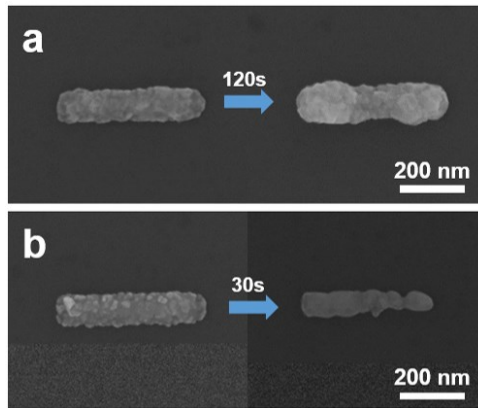


Fig. S9 SEM images of Au nanorods (NRs) before and after the laser irradiation. Irradiation power: 1 mW. HAuCl_4 . Concentration: (a): 10 mM. (b): 30 mM. The Au NRs were fabricated via e-beam lithography without any surface ligands. The irradiation results show similar trend as Au NPs: higher concentration of HAuCl_4 leads to etching of the Au NRs while lower concentration HAuCl_4 leads to growth at ends.

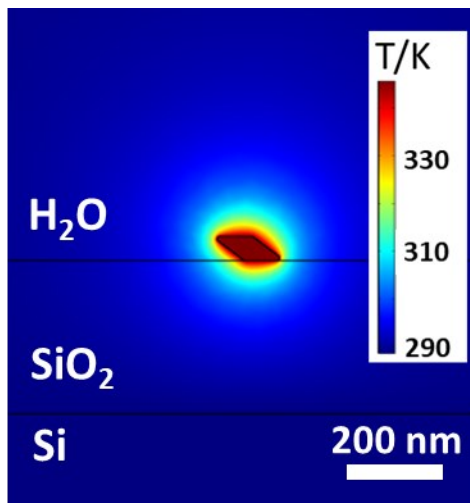


Fig. S10 Temperature distribution around the Au BPN on SiO_2/Si substrate with water medium. Irradiation power: 1 mW.